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Dated: February 28, 2005

Signature: Marla L. Hudson  
(Marla L. Hudson)

Docket No.: 30203/38233  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Evren Eryurek et al.

Application No.: 10/085,445

Confirmation No.: 1836

Filed: February 28, 2002

Art Unit: 2121

For: FIDUCIAL TECHNIQUE FOR ESTIMATING  
AND USING DEGRADATION LEVELS IN A  
PROCESS PLANT

Examiner: Thomas K. Pham

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. § 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated December 28, 2004, rejecting claims 1-27 and 29-35, applicants respectfully request reconsideration of the application in view of the following amendments and remarks.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.

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